

**Notice of References Cited**

Application/Control No.

10/581,849

Applicant(s)/Patent Under  
Reexamination  
LEISING ET AL.

Examiner

ROBERT TAVLYKAEV

Art Unit

2883

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N	GB 2155194 A	09-1985	Great Britain	Bennion	G02F 1/19
	O	EP 0273703 A2	07-1988	US	Elchelberger	H01L 21/00
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Nanostructuring in submicron-level waveguides with femtosecond laser pulses," by Li et al, Optics Communications, vol. 212, pp. 159 – 163, Oct 2002.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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